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To: United States Patent and Trademark Office

Attention: Peter B. Kim

From: Jason D. Eisenberg

Pages (including cover sheet):

Fax No: (571) 273-8300

Date: March 18, 2008

Re: Appl. No. 10/811,070; Filed March 29, 2004

For: Lithographic Apparatus and Device

Manufacturing Method
Inventors: Van Der Feltz et al.

Your Reference: 10/811,070

Our Reference: 1857.2780000

## Message

Applicant Initiated Interview Request Form attached.

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U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

Applicant Initiated Interview Request Form							
Application No.: 10/811,070 First Named Applicant: Gustaaf Willem Van Der Feltz  Examiner: Peter B. Kim Art Unit: 2851 Status of Application: After Final							
	nberg	_ (2) Shubh Seng			RECEIVED		
(3)		_ (4)					
Proposed Date of Interview: March 20, 2008 Proposed Time: 2:00-3:00 PM (AM/PM)							
Type of Interview Requested: (1) [X] Telephonic (2) [ ] Personal (3) [ ] Video Conference							
Exhibit To Be Show If yes, provide brief	n or Demonstra description:	ated: []YES	[X] NO		-		
Issues To Be Discussed							
Issues	Claims/		Discussed	Agreed	Not Agreed		
(Rej., Obj., etc)	Fig. #s	Prior Art					
(1)_Rej	13, 23, 33	- All	[]	[]	[]		
(2)			[]	[]	[]		
(3)			[]	[]	[]		
(4)			[]	. []	[]		
[ ] Continuation Sh	eet Attached						
Brief Description of Amended claims t	f Arguments to o add allowable	be Presented: e subject matter to sy	stem claims.				
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					<del></del>		
NOTE: This form sl (see MPEP § 713.01). This application will	hould be complet , not be delayed fr	e above-identified appoint and subsection of appoint and subsection issue because of appoint to file a statement.	mitted to the exam dicant's failure to s	ubmit a written	record of this		
Applicant/Applic	ant's Representa	itive Signature	Exa	miner/SPE Sign	nature		
Jaso	on D. Eisenberg	<u> </u>					
Typed/Printed Nam	e of Applicant o	r Representative					
Registratio	43,447 on Number, if ap	plicable			,		

This collection of information is required by 37 CFR 1.133. The information is required to obtain or retain a benefit by the public which is to file (and by the USFTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.11 and 1.14. This collection is estimated to take 21 minutes to complete, including gathering, preparing, and submitting the completed application form to the USFTO. Time will vary depending upon the Individual case. Any comments on the amount of time you require to complete this form and/or auguestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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